



image.

2871

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: T. TSUJIMURA et al.

SERIAL NO.: 09/682,002

ART UNIT: 2871

FILED: 07/06/2001

EXAMINER: Tai V. DUONG

TITLE: ACTIVE MATRIX SUBSTRATE AND MANUFACTURING METHOD
THEREOF

ATTORNEY DOCKET NO.: JP920000098US1

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT AND
CETRIFICATION UNDER 37 C.F.R. 1.97(e) (1)

Sir:

Pursuant to the duty of disclosure, the attention of the Examiner is directed to the documents cited on the attached form PTO-1449 (substitute). These four documents were cited in Applicants' corresponding application in Japan in an office action issued on August 19, 2003. Copies of these documents, including abstracts in English, as well as a copy of the Japanese office action are enclosed herewith. The latter indicates, by reference to specific numbers, the claims and the documents of relevance. It is respectfully requested that the Examiner considered these documents, and make them of record.

I hereby certify that each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

It is believed that no fee is required for the filing of this paper. However, if any fee is required please charge deposit account no. 50-0510.

Respectfully submitted,

David Aker

9/13/03

David Aker, Reg. No. 29,277
23 Southern Road
Hartsdale, NY 10530
Tel. & Fax 914 674-1094

Date

Certificate of Mailing

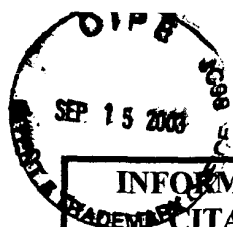
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

SEPTEMBER 13, 2003

Date

David Aker

Name of Person Making Deposit

**INFORMATION DISCLOSURE
CITATION FORM FOR
PATENT APPLICATION
(FORM PTO-1449)
(Substitute)**

Docket No.: JP920000098US1

Serial No.: 09/682,002

Applicant(s): Tsujimura et al.

Filing Date: 07/06/01

Group: 2871

U.S. PATENTS

Initials	Patent Number	Issue Date	Name	Class	Sub-class	Filing date

FOREIGN PATENT DOCUMENTS

Initials	Document Number	Date	Country	Name	Translation? Yes/No/n/a
	08-201849	08/1996	Japan	Masatoshi et al.	Yes
	05-113580	05/1993	Japan	Noritoshi et al	Yes
	61-161764	07/1986	Japan	Yoshiharu	Yes
	61-188967	08/1986	Japan	Tadanori et al.	Yes

OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)

Examiner's Signature:

Date Considered:

Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered.
Include a copy of this citation form with your next correspondence to the Applicant(s).